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Docket: 0756-711

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In re PATENT application of)
Shunpei YAMAZAKI et al.) ,/
Serial No. 07/852,517) Art Unit 2503
Filed: March 17, 1992)
For: SEMICONDUCTOR MATERIAL)
AND METHOD FOR FORMING)
THE SAME AND THIN FILM) RECEIVED
TRANSISTOR) June 17, 1992, 3 1992
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GROUP 250

TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Honorable Commissioner of Patents and Trademarks Washington, D. C. 20231

Sir:

At the time of filing the above-referenced application, a right of priority under 35 USC 119 was claimed in view of Application No. 3-080799, filed March 18, 1991 Japan.

Submitted herewith is the certified copy of the priority document to perfect the claim for priority.

Acknowledgment is respectfully requested.

Respectfully submitted,

Gerald J. Ferguson, J.

Registration No. 23,016

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